

 <p style="text-align: center;">INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>	Docket Number (Optional) SWO-0002	Application Number 10/705,591
	Applicant(s) Jeong-hwan LEE, et al.	
	Filing Date 11-10-2003	Group Art Unit 2875

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
JMH		2001-166306	6-22-2001	JAPAN w/English abstract				✓
JMH		2003-84110	3-19-2003	JAPAN w/English abstract				✓
JMH		2001-83507	3-30-2001	JAPAN w/English abstract				✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER /Jason Han/ (09/18/2006)	DATE CONSIDERED 09/18/2006
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.